



Sheet 1 of 1

Subst. Form PTO-1449				Docket Number (Optional) SAM-0554		Application Number 10/823,420		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)				Applicant Seung-hwan Lee, et al.				
				Filing Date April 13, 2004		Group Art Unit 2811		
U. S. Patent Documents								
EXAMINER INITIALS		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
Al	AA	5,012,306	04/30/91	Tasch, Jr., et al.	357	23.4	09/22/89	
Al	AB	6,022,771	02/08/00	Ma, et al.	438	230	01/25/99	
Al	AC	6,235,568	05/22/01	Murthy, et al.	438	231	01/22/99	
Al	AD	6,277,677	08/21/01	Lee	438	142	04/10/00	
Al	AE	6,326,664	12/04/01	Chau, et al.	257	344	11/14/97	
Al	AF	6,445,042	09/03/02	Yu, et al.	257	369	10/13/00	
Al	AG	2001/0034085	10/25/01	Nakayama, et al.	438	140	03/30/01	
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
Al	AL	EP 0 480 446	12/10/90	Europe	H01L	21/336	X	
Al	AM	EP 0 780 907	25/06/97	Europe	H01L	29/78	X	
Al	AN	WO 03/075345	12/09/03	WO	H01L	21/8238	X	
	AO							
	AP							
	AQ							
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER <i>Andy Hwang</i>				DATE CONSIDERED <i>08/05/05</i>				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy with next communication to applicant.								